

Free Silicon Conference 2023 Superconducting quantum processor design with KQCircuits®

Pavel Smirnov Software Engineer, Design and Simulation team



github.com/iqm-finland/KQCircuits

0

CI passing DOI 10.5281/zenodo.4944796 License GPLv3



What is KQCircuits?

- A plug-in for KLayout (<u>www.klayout.de</u>), SALT package available
- An open-source framework for designing superconducting circuit geometry
 - Multi-layer 2-dimensional -> allows flip chip design
- Libraries of standard, usable Elements and Chips
- Focus on parametrized design enables large scale and reusable designs
- Integrates with finite element simulation tools
- Tools for quality control: design rules, netlist export, FEM simulations

IQM What does KQCircuits provide?



Export to Finite Element simulations Elmer (open source) Ansys (HFSS, Q3D) Sonnet





QPU design process



Superconducting Quantum processing unit

- Slab of Si covered by metal film
- Geometry etched to the film
- Consists of elements
 - Qubits
 - Couplers
 - Readout resonators
 - Drivelines and fluxlines
 - Probelines



Further reading on the principles of quantum chips:

P Krantz et al, *A quantum engineer's guide to superconducting qubits*, Applied Physics Reviews **6**, 021318 (2019)

J. Koch et al, *Charge insensitive qubit design derived from the Cooper pair box,* Phys. Rev. A 76, 042319 (2007)





Implement your own parametric elements



@add_parameters_from(FingerCapacitorSquare, "fixed_length", "a2", "b2", finger_width=10, finger_gap=5)
class SmoothCapacitor(Element):

"""The PCell declaration for a smooth finger capacitor.

SmoothCapacitor is a finger capacitor, which has continuous geometry changes through the capacitance range. This leads to continuous capacitance function, which enables using capacitor inside numerical optimization methods.

Capacitance range is achieved by changing single parameter called `finger_control`.

* Instano	Instance Properties			Cell Tap	cell
	Del Smooth Capacitor Library [Hernanti Library - S	speccerelating	quantum circuit library for elements.	
	Geametry PCell parameters	14			
	Turn radius	100	june .		
	Margin of the protection layer	5	juri .		
	chip face (Ds list	1t1.2b1.1b1.2t1			
	Name displayed in GUI lengty for defaulti				
	Add opposite face protection too				
	Continuously adjust finger number	2.1			
	Gap between ground and Roger	20	(Jan		
	Width of center conductor on the other end	4	para.		
	Width of gap on the other end	4	1 APR		
	Fixed length of element, 0 for auto-length	0	and a set		
	width of a linger	3.0	um.		
	tiap between the fingers	5	jum .		-
	Show parameter names				
	Coordinates in database units				
	Absolute Decrumulated) transformations				
				User Properties Show Cell in Time Instantia	tion
	I Count State			OK Car	cet

Tools for composing complex chip layouts

- Composite waveguides
 - Inline elements (capacitors, splitters, ...)
 - Adjustable-length segments
- Hybrid GUI + code workflow Sketch layout in GUI

Generate & edit Python code View / edit / route in GUI Export & verification





Export masks

demo.add mask layout (["---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "DE1", "DE1", "DE1", "DE1", "DE1", "----", "----", "----", "----", " "---", "DE1", "DE1", "---", "---", "---", "---", "DE1", "DE1", "---", "---", "DE1", "---", "---", "---", "---", "---", "---", "---", "---", "DE1", "---", "DE1", "---", "DE1", "---", "DE1", "---", "---", "DE1", "---", "DE1", "---", "---", "---", "---", "DE1", "---", "DE1", "---", "DE1", "---", "---", "---", "---", "DE1", "---", "DE1", "---", "DE1", "---", "DE1", "DE1","DE1","DE1","DE1","DE1","DE1"," "DE1", "---", "CH1", "CH1", "---", "---", "CH1", "CH1", "CH1", "DE1", "---", "DE1", "---", "---", "CH1", "CH1", "---", "---", "CH1", "CH1", "---", "DE1", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "DE1", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "---", "DEI", "----", "CHI", "----", "----", "----", "----", "----", "CHI", "----", "DEI", "DE1" "---", "---", "CH1", "---", "---", "---", "---", "CH1", "---", "DE1", "DE1", "---", "---", "CH1", "CH1", "CH1", "CH1", "---", "---", "DE1", "---" "---", "DE1", "---", "---", "---", "---", "---", "---", "---", "---", "DE1", "---", "DE1", "---", "DE1", "---", "---", "---", "DE1", "DE1", "---", "---", "---", "---", "DE1", "DE1", "---", "---", "---", "---", "---", "DE1", "DE1", "DE1", "DE1", "DE1", "---", ["----", "----", "----", "----", "----", "----", "----", "----", "----", "----", "----", "----", "----", "----", "ltl", layers to mask=layers to mask)

- Merge metallization layers
- Generate masks for wafer-scale lithography
- Adds alignment markers
- Configurable which layers are exported to a mask
- Optionally invert layer polarity
- Export mask files as well as individual chips and related files



Verification

- Netlist verification
 - Target: detect technical errors such as wrong segment length
- KLayout's Design Rule Check (DRC)
 - Checks spacing of structures in critical layers
 - Checks crossing waveguides
 - Target: detect simple geometry errors
- Custom FEM verification
 - Estimate e.g. crosstalk effects
 - KQC export + manual simulation work

Simulations

[1] Z. K. Minev et al., 'Energy-participation quantization of Josephson circuits', npj Quantum Inf, vol. 7, no. 1, Art. no. 1, Aug. 2021
 [2] P. Råback et al., 'Elmer'. CSC - IT Center for Science, Available: github.com/ElmerCSC/elmerfem

• Ansys

- Q3D capacitance extraction using method of moments
- HFSS S matrix extraction
- HFSS Eigenmode with ideal inductors modelling junctions/SQUIDs
- pyEPR support [1]
- Elmer (Open source FEM solver by CSC Finland) [2]
 - 3D capacitance using FEM
 - 2D cross-sections in Elmer
 - Kinetic inductance for some penetration depth
 - Energy participation ratio (EPR)
- FEM component in KQC workflow quite replaceable with other third-party simulator software as we learn about them (e.g. Sonnet, AWS Palace)



https://www.csc.fi/fi/web/elmer



https://www.ansys.com/

https://www.sonnetsoftware.com/



https://awslabs.github.io/palace/stable/

Electromagnetic simulations











Meshing





- Divides space into a mesh, simulation value sampled at each mesh node
- Regions where simulation value changes a lot (higher gradient) should have more dense meshing
- Can be handcrafted (Gmsh), but adaptive meshing reduces trial-and-error
- Ansys has adaptive meshing, Elmer <u>parallelised</u> adaptive meshing coming soon





https://wiki.f-si.org/index.php?title=KLayout_XSection_tool_-_Deep_insights_or_nonsense_in_colors%3F

Using XSection to study energy participation ratio (EPR)

Cross-section of planar geometry with lossy interfaces MA, MS & SA







Thank you!



Fast Lane to Quantum Advantage